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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/816,896	04/05/2004	Helmut Haidner	Q80898	2639	
	23373 7590 08/09/2007 SUGHRUE MION, PLLC			EXAMINER	
2100 PENNSYLVÁNIA AVENUE, N.W. SUITE 800			LEE, HWA S		
WASHINGTON, DC 20037			ART UNIT	PAPER NUMBER	
			2886		
			MAIL DATE	DELIVERY MODE	
		•	08/09/2007	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)				
	10/816,896	HAIDNER ET AL				
Office Action Summary	Examiner	Art Unit				
	Andrew Hwa S. Lee	2886				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tim vill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	the mailing date of this communication. D (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on 29 Mi	ay 2007.					
2a) ☐ This action is FINAL . 2b) ☒ This	This action is FINAL. 2b)⊠ This action is non-final.					
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims						
4)⊠ Claim(s) <u>1-6</u> is/are pending in the application.						
4a) Of the above claim(s) is/are withdrawn from consideration.						
5)⊠ Claim(s) <u>2-5</u> is/are allowed.						
6)⊠ Claim(s) <u>1;6</u> is/are rejected.	6)⊠ Claim(s) <u>1;6</u> is/are rejected.					
	7) Claim(s) is/are objected to.					
8) Claim(s) are subject to restriction and/or	r election requirement.					
Application Papers	·					
9) The specification is objected to by the Examine	r.					
10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).						
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign	priority under 35 U.S.C. § 119(a)	-(d) or (f).				
a) ☐ All b) ☐ Some * c) ☐ None of:						
1. Certified copies of the priority documents have been received.						
2. Certified copies of the priority documents have been received in Application No						
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).						
* See the attached detailed Office action for a list of the certified copies not received.						
•		•				
Attachment(s)						
1) Notice of References Cited (PTO-892)	4) Interview Summary					
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date 5) Notice of Informal Patent Application						
Paper No(s)/Mail Date 6) Other:						

U.S. Patent and Trademark Office PTOL-326 (Rev. 08-06) Application/Control Number: 10/816,896

Art Unit: 2886

DETAILED ACTION

· Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- (e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371(c) of this title before the invention thereof by the applicant for patent.

The changes made to 35 U.S.C. 102(e) by the American Inventors Protection Act of 1999 (AIPA) and the Intellectual Property and High Technology Technical Amendments Act of 2002 do not apply when the reference is a U.S. patent resulting directly or indirectly from an international application filed before November 29, 2000. Therefore, the prior art date of the reference is determined under 35 U.S.C. 102(e) prior to the amendment by the AIPA (pre-AIPA 35 U.S.C. 102(e)).

2. Claims 1 and 6 are rejected under 35 U.S.C. 102(e) as being anticipated by Wegmann (US 7,088,458).

Application/Control Number: 10/816,896 Page 3

Art Unit: 2886

Wegmann shows measuring an optical imaging system comprising:

a mask structure (6) which is arranged on an object side, and

a grating structure (18,14) which is arranged on an image side,

wherein

; the mask structure comprises one or more one-dimensional mask structure patterns, and

the grating structure to be arranged on the image side comprises one or more two-dimensional

grating structure patterns (claim 2) or

wherein the mask structure comprises one or more two-dimensional mask structure

patterns since the pinholes and the test beam windows create a two-dimensional pattern, and the

grating structure comprises one or more one-dimensional grating structure patterns.

Allowable Subject Matter

3. Claims 2-5 are allowed.

4. The following is a statement of reasons for the indication of allowable subject matter:

Claims 2-5 are allowable for reasons argued in Applicant's response of 9/18/06.

Response to Arguments

Applicant argues that Wegman does not disclose the mask structure and the grating structure having a different dimensionality. However, the claim does not limit what aspect of "dimensionality" is being claimed. Any structural difference between the mask structure and the grating structure would meet the claimed limitation of "different dimensionality). Figure 10 shows a grating drive 18 having a grating (14) has a different structural arrangement than the mask. The mask can comprise a pinhole and the test beam window. Therefore, the mask structure has a different dimensionality that the grating structure. Claim 6 does not recited the limitation argued by Applicant that the mask structure has a different dimensionality that the grating structure, thus that limitation is not read into the claim.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andrew Hwa S. Lee whose telephone number is 571-272-2419. The examiner can normally be reached on Tue-Fr.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tarifur R. Chowdhury can be reached on 571-272-2800. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Application/Control Number: 10/816,896 Page 5

Art Unit: 2886

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Andrew Hwa S. Lee Primary Examiner

Art Unit 2886